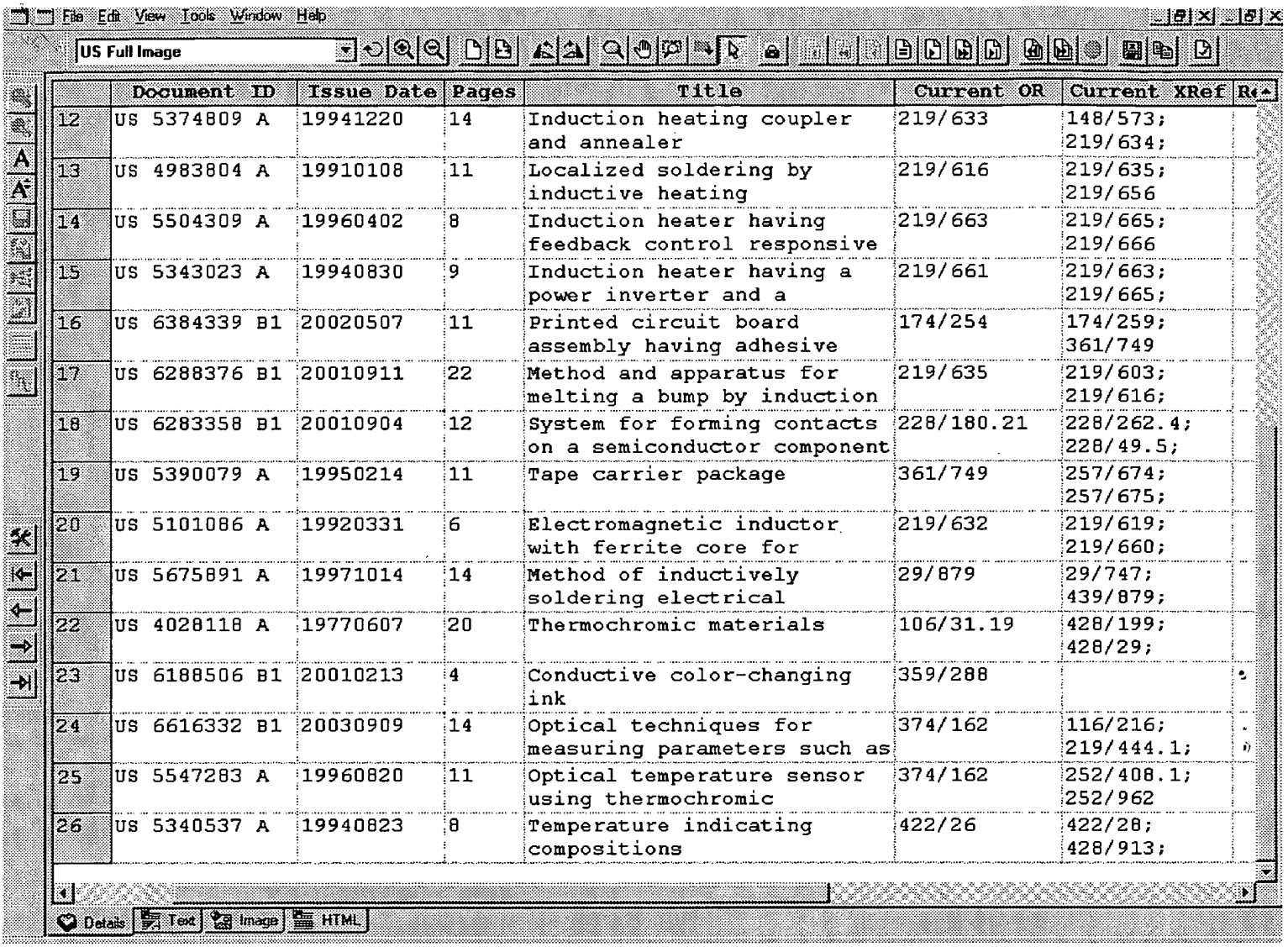
L Number	Hits	Search Text	DB	Time stamp
1	0	heat$1indicat$3 adj (paint strip)	USPAT; EPO; JPO	2003/10/18 11:13
2	4	(heat adj indicat$3 heat$1indicat$3) adj (paint strip)	USPAT; EPO; JPO	2003/10/18 11:15
3	3	heat adj indicat$3 with (paint strip material) and heat$3 and substrate and circuit	USPAT; EPO; JPO	2003/10/18 11:18
4	0	heat adj indicator and temperature and anneal and heat$3 and substrate and circuit	USPAT; EPO; JPO	2003/10/18 11:19
5	23	heat$3 adj1 indicator and temperature and substrate and circuit	USPAT; EPO; JPO	2003/10/18 11:23
6	19	("4028118" | "4032687" | "4142782" | "4360780" | "4379816" | "4497881" | "4702563" | "4702564" | "4725462" | "4726661" | "4727006" | "4737020" | "4835475" | "4835476" | "5015544" | "5059895" | "5156931" | "5371657" | "5466654").PN.	USPAT	2003/10/18 11:20
7	109542	(temperature heat$3 adj1 indicator) and temperature and substrate and circuit	USPAT; EPO; JPO	2003/10/18 11:24
8	201	(temperature heat$3) adj1 indicator and temperature and substrate and circuit	USPAT; EPO; JPO	2003/10/18 11:27
9	24	((temperature heat$3) adj1 indicator and temperature and substrate and circuit) and anneal$3	USPAT; EPO; JPO	2003/10/18 11:24
10	7	(temperature heat$3) adj1 indicator with (paint$3 strip) and temperature and substrate and circuit	USPAT; EPO; JPO	2003/10/18 12:43
13	1	(temperature heat$3) adj1 indicator with (paint$3 strip) and substrate and circuit and (oven furnace)	USPAT; EPO; JPO	2003/10/18 12:44
14	15	(temperature heat$3) adj1 indicator with (paint$3 strip) and substrate and (oven furnace)	USPAT; EPO; JPO	2003/10/18 13:32
15	4	5340537.URPN.	USPAT	2003/10/18 13:21
16	11	(temperature heat$3) adj1 indicator with (paint$3 strip) and surface with substrate and (oven furnace)	USPAT; EPO; JPO	2003/10/18 13:32
-	2	heating with microelectronic.ti.	USPAT; US-PGPUB	2003/09/20 11:19
-	18	heating and microelectronic and oscillat$3 with electro$1magnetic and field	USPAT; EPO; JPO	2003/09/20 11:21
-	26	heat$3 and microelectronic and oscillat$3 with electro$1magnetic and field	USPAT; EPO; JPO	2003/09/20 11:24
-	92	heat$3 with oscillat$3 with electro$1magnetic with field	USPAT; EPO; JPO	2003/09/20 11:24
-	3	"6150186"	USPAT	2003/09/20 14:35
-	100	"5476211"	USPAT	2003/09/20 14:39
-	51	"5917707"	USPAT	2003/09/20 14:40
-	8	"6336269"	USPAT	2003/09/20 14:40
-	272	micro$1electronic and heat$3 and cool$3 and oscillat$3	USPAT; EPO; JPO	2003/10/15 19:06
-	95	(micro$1electronic and heat$3 and cool$3 and oscillat$3) and electro$1magnetic	USPAT; EPO; JPO	2003/10/15 19:07
-	95	29/$.ccls. and 219/$.ccls. and 148/$.ccls.	USPAT; EPO; JPO	2003/10/16 13:48
-	41	(29/$.ccls. and 219/$.ccls. and 148/$.ccls.) and heat$3	USPAT; EPO; JPO	2003/10/16 13:49
-	3	((29/$.ccls. and 219/$.ccls. and 148/$.ccls.) and heat$3) and electro$1magnetic	USPAT; EPO; JPO	2003/10/16 13:50

-	3	((29/$.ccls. and 219/$.ccls. and 148/$.ccls.) and heat$3) and oscillat$3	USPAT; EPO; JPO	2003/10/16 13:51
-	4	((29/$.ccls. and 219/$.ccls. and 148/$.ccls.) and heat$3) and wave	USPAT; EPO; JPO	2003/10/16 13:54
-	448	(heat$1treatment heat adj1 treatment) and electromagnetic adj field	USPAT; EPO; JPO	2003/10/16 14:17
-	305	((heat$1treatment heat adj1 treatment) and electromagnetic adj field) and frequency	USPAT; EPO; JPO	2003/10/16 13:56
-	64	(((heat$1treatment heat adj1 treatment) and electromagnetic adj field) and frequency) and cool$3 and substrate	USPAT; EPO; JPO	2003/10/16 14:16
-	466	(heat$1treatment heat adj1 treatment) and (electromagnetic adj field electro$1magnetic adj field)	USPAT; EPO; JPO	2003/10/16 14:18
-	39	((heat$1treatment heat adj1 treatment) and (electromagnetic adj field electro$1magnetic adj field)) and generat$3 and resonant adj frequency	USPAT; EPO; JPO	2003/10/16 14:41
-	124	oscillating adj electromagnetic adj field and heat$3	USPAT; EPO; JPO	2003/10/16 15:08
-	4	(oscillating adj electromagnetic adj field and heat$3) and micro$1electronic	USPAT; EPO; JPO	2003/10/16 15:09
-	898	heat$3 and cool$3 and micro$1electronic and substrate and frequency and temperature	USPAT; EPO; JPO	2003/10/16 15:10
-	429	heat$3 and cool$3 and micro$1electronic and substrate and frequency and metallic and temperature	USPAT; EPO; JPO	2003/10/16 15:11
-	75	(heat$3 and cool$3 and micro$1electronic and substrate and frequency and metallic and temperature) and oven	USPAT; EPO; JPO	2003/10/16 15:38
-	55	(oscillating adj electromagnetic adj field and heat$3) and cool$3 and temperature	USPAT; EPO; JPO	2003/10/16 15:40
-	151	(heat$3 and cool$3 and micro$1electronic and substrate and frequency and metallic and temperature) and microwave	USPAT; EPO; JPO	2003/10/16 15:41
-	4	("2903543" | "4522834" | "4974503" | "4980530").PN.	USPAT	2003/10/16 16:31
-	2	("4978501" | "5035858").PN.	USPAT	2003/10/16 16:59
-	4	("4422442" | "4801343" | "5047605" | "5994680").PN.	USPAT	2003/10/16 17:05
-	435	micro$1electronic and anneal$3 and (electro$1magnetic microwave)	USPAT; EPO; JPO	2003/10/16 17:23
-	256	micro$1electronic and anneal$3 and (electro$1magnetic microwave) and frequency	USPAT; EPO; JPO	2003/10/16 17:24
-	59	(micro$1electronic and anneal$3 and (electro$1magnetic microwave) and frequency) and spring	USPAT; EPO; JPO	2003/10/16 17:32
-	68	(micro$1electronic and anneal$3 and (electro$1magnetic microwave) and frequency) and resonant	USPAT; EPO; JPO	2003/10/16 18:02
-	235	148/525,565.ccls. and heat$3 and cool$3	USPAT; EPO; JPO	2003/10/16 18:04
-	1	(148/525,565.ccls. and heat$3 and cool$3) and micro$1electronic	USPAT; EPO; JPO	2003/10/16 18:03
-	36	148/525,565.ccls. and heat$3 and electro$1magnetic	USPAT; EPO; JPO	2003/10/16 18:10
-	6	("2491134" | "3615924" | "3660630" | "4181845" | "4312685" | "4420346").PN.	USPAT	2003/10/16 18:07
-	8	4872926.URPN.	USPAT	2003/10/16 18:08
-	205	219/602,605,615,616,632,635,636,764,765,770.ccls. and heat$3 and electro$1magnetic	USPAT; EPO; JPO	2003/10/16 18:16
-	0	(219/602,605,615,616,632,635,636,764,765,770.ccls. and heat$3 and electro$1magnetic) and micro$1electronic	USPAT; EPO; JPO	2003/10/16 18:12

-	151	(219/602,605,615,616,632,635,636,764,765,77 and heat$3 and electro$1magnetic) and	USPAT; EPO; JPO	2003/10/16 18:12
-	39	(219/602,605,615,616,632,635,636,764,765,77 and heat$3 and electro$1magnetic) and frequency) and tun$3	USPAT; EPO; JPO	2003/10/16 18:12
-	0	29/dig13.ccls. and heat$3 and electro$1magnetic	USPAT; EPO; JPO	2003/10/16 18:17
-	0	29/dig21.ccls. and heat$3 and electro$1magnetic	USPAT; EPO; JPO	2003/10/16 18:17
-	24	29/dig$.ccls. and heat$3 and electro$1magnetic	USPAT; EPO; JPO	2003/10/16 18:20
-	9	29/dig$.ccls. and heat$3 and microwave	USPAT; EPO; JPO	2003/10/16 19:42
-	1566	156/$.ccls. and heat$3 and microwave	USPAT; EPO; JPO	2003/10/16 19:50
-	78	(156/$.ccls. and heat$3 and microwave) and microelectronic	USPAT; EPO; JPO	2003/10/16 19:43
-	68	((156/$.ccls. and heat$3 and microwave) and microelectronic) and frequency	USPAT; EPO; JPO	2003/10/16 19:43
-	31	(((156/$.ccls. and heat$3 and microwave) and microelectronic) and frequency) and electro$1magnetic	USPAT; EPO; JPO	2003/10/16 19:44
-	10	156/$.ccls. and heat$3 and electro$1magnetic and anneal$3 and cool$3 and metallic adj material	USPAT; EPO; JPO	2003/10/16 20:09
-	39	electromagnetic and anneal$3 and heat$3 with treat$4 and frequency and resonant and tun$4	USPAT; EPO; JPO	2003/10/16 20:14
-	30	(electromagnetic and anneal$3 and heat$3 with treat$4 and frequency and resonant and tun$4) and (device structure)	USPAT; EPO; JPO	2003/10/16 20:11
-	925595	electromagnetic same heat$3 same (structure device) and anneal$3 and heat$3 with treat$4 frequency	USPAT; EPO; JPO	2003/10/16 20:15
-	67	electromagnetic same heat$3 same (structure device) and anneal$3 and heat$3 with treat$4 and frequency	USPAT; EPO; JPO	2003/10/16 20:41
-	614	electromagnetic same heat$3 same (structure device) and cool$3 and heat$3 with treat$4	USPAT; EPO; JPO	2003/10/16 20:42
-	44	(electromagnetic same heat$3 same (structure device) and cool$3 and heat$3 with treat$4) and metallic adj material	USPAT; EPO; JPO	2003/10/16 20:42
-	2456	inductive adj heating	USPAT; EPO; JPO	2003/10/17 10:00
-	23	(inductive adj heating) and micro$1electronic	USPAT; EPO; JPO	2003/10/17 10:04
-	0	(inductive adj heating) and non$1metallic adj substrate	USPAT; EPO; JPO	2003/10/17 10:05
-	0	(inductive adj heating) and hairpin adj coil	USPAT; EPO; JPO	2003/10/17 10:05
-	0	(inductive adj heating) and hair$1pin adj coil	USPAT; EPO; JPO	2003/10/17 10:05
-	99	(inductive adj heating) and resonant adj frequency	USPAT; EPO; JPO	2003/10/17 10:06
-	22	((inductive adj heating) and resonant adj frequency) and ferromagnetic	USPAT; EPO; JPO	2003/10/17 10:11
-	231	(inductive adj heating) and electromagnetic adj field	USPAT; EPO; JPO	2003/10/17 10:12
-	50	((inductive adj heating) and electromagnetic adj field) and heat$3 and substrate	USPAT; EPO; JPO	2003/10/17 10:25

-	145	("1566500" | "2378801" | "2429819" | "2549930" | "3272954" | "3466528" | "3562054" | "3574031" | "3609104" | "3612803" | "3657038" | "3671371" | "3710062" | "3733231" | "3737611" | "3743808" | "3746825" | "3816690" | "3823362" | "3833439" | "3845268" | "3846204" | "3902940" | "3953700" | "3953783" | "3996402" | "4017701" | "4018642" | "4029837" | "4038120" | "4112286" | "4120712" | "4123305" | "4177494" | "4234824" | "4268737" | "4277667" | "4280038" | "4293363" | "4327268" | "4355222" | "4382275" | "4410457" | "4420876" | "4467165" | "4481709" | "4483896" | "4506131" | "4511956" | "4516104" | "4521659" | "4528057" | "4543555" | "4567094" | "4578553" | "4581158" | "4602139" | "4637199" | "4650947" | "4654495" | "4668851" | "4677535" | "4707402" | "4749833" | "4762864" | "4763093" | "4769519" | "4776980" | "4816633" | "4841706" | "4845332" | "4847746" | "4853832" | "4897518" | "4941936" | "4950348" | "4969968" | "RE33467" | "4978825" | "4983804" | "5025123" | "5030816" | "5031088" | "5057370" | "5075034" | "5093545" | "5123989" | "5124203" | "5128504" | "5134000" | "5134261" | "5170025" | "5198053" | "5222185" | "5225287" | "5266764" | "5272216" | "5286941" | "5286952" | "5298194" | "5313034" | "5313037" | "5317045" | "5328539" | "5340428" | "5343023" | "5350902" | "5374808" | "5374809" | "5376403" | "5378879" | "5391595" | "5438181" | "5483043" | "5490759" | "5500511" | "5504309" | "5508496" | "5534097" | "5573613" | "5639847" | "5705796" | "5710413" | "5717191" | "5723849" | "5773799" | "5799653" | "5830389" | "5837088" | "5874713" | "5877552" | "5916469" | "5919387" | "5925455" | "5932057" | "5935369" | "6043471" | "6056844" | "RE36787" | "6083558" | "6100696" | "6110565" | "6137093" | "6229127" | "6302178").PN.	USPAT	2003/10/17 10:13
-	73	((inductive adj heating) and electromagnetic adj field) and heat$3 with (electronic circuit)	USPAT; EPO; JPO	2003/10/17 10:39
-	6	((inductive adj heating) and electromagnetic adj field) and heat$3 with electronic with (device circuit)	USPAT; EPO; JPO	2003/10/17 10:49
-	9	4996405.URPN.	USPAT	2003/10/17 10:40
-	26	((inductive adj heating) and electromagnetic adj field) and heat$3 adj treat$4	USPAT; EPO; JPO	2003/10/17 10:52
-	221	microelectronic with structure and heat$3 adj treat$4	USPAT; EPO; JPO	2003/10/17 10:53
-	207	(microelectronic with structure and heat$3 adj treat$4) and substrate	USPAT; EPO; JPO	2003/10/17 10:53
-	84	((microelectronic with structure and heat$3 adj treat$4) and substrate) and metallic	USPAT; EPO; JPO	2003/10/17 10:53
-	68	(((microelectronic with structure and heat$3 adj treat$4) and substrate) and metallic) and insulat$4	USPAT; EPO; JPO	2003/10/17 10:54

-	11	("2762892" | "3467806" | "4327265" | "4431891" | "4642442" | "4659912" | "4749833" | "4771151" | "4789767" | "4795870" | "4806107").PN.	USPAT	2003/10/17 14:33
-	18	4983804.URPN.	USPAT	2003/10/17 14:35
-	25	4969968.URPN.	USPAT	2003/10/17 14:40
-	554	heat$3 and heat$3 adj treat$4 and micro$1electronic and cool$3	USPAT; US-PGPUB; EPO; JPO	2003/10/17 16:03
-	174	(heat$3 and heat$3 adj treat$4 and micro$1electronic and cool$3) and substrate and metallic	USPAT; US-PGPUB; EPO; JPO	2003/10/17 16:03
-	45	((heat$3 and heat$3 adj treat$4 and micro$1electronic and cool$3) and substrate and metallic) and (electromagnetic oscillat$4)	USPAT; US-PGPUB; EPO; JPO	2003/10/17 16:12
-	0	heat$3 and cool$3 and (electromagnetic oscillat$4) with field and electronic with component with heat$3 with treat$4	USPAT; EPO; JPO	2003/10/17 16:14
-	14	heat$3 and cool$3 and (electromagnetic oscillat$4) with field and electronic with heat$3 with treat$4	USPAT; EPO; JPO	2003/10/17 16:14
-	22	("3725629" | "3946349" | "4160967" | "4222023" | "4296295" | "4549056" | "4950348" | "5101086" | "5208433" | "5319179" | "5343023" | "5352871" | "5412184" | "5461215" | "5466916" | "5504309" | "5526561" | "5714738" | "5721413" | "5739506" | "5773799" | "5919387").PN.	USPAT	2003/10/17 16:58
-	1	6229126.URPN.	USPAT	2003/10/17 16:38
-	0	4503306.URPN.	USPAT	2003/10/17 16:53
-	0	4503306.URPN.	USPAT	2003/10/17 16:53
-	16	microelectronic and heat$3 adj treat$4 and spring with structure	USPAT; EPO; JPO	2003/10/17 17:11
-	316	microelectronic and heat$3 adj treat$4 and oven	USPAT; EPO; JPO	2003/10/17 17:11
-	210	microelectronic and heat$3 adj treat$4 and (oven furnace) and metallic	USPAT; EPO; JPO	2003/10/17 17:13
-	8	microelectronic and heat$3 adj treat$4 and inductive with heat$3	USPAT; EPO; JPO	2003/10/17 18:03
-	9	electromagnetic adj field and heat$3 adj treat$4 with electronic	USPAT; EPO; JPO	2003/10/17 18:05
-	26	electromagnetic adj field and heat$3 adj treat$4 and inductive adj heat$3	USPAT; EPO; JPO	2003/10/17 18:08
-	1	electromagnetic adj field and (electric$2 circuit) with (component device) with treat$4 and inductive adj heat$3	USPAT; EPO; JPO	2003/10/17 18:10
-	92	electromagnetic adj field and (electric$2 circuit) with (component device) and inductive adj heat$3	USPAT; EPO; JPO	2003/10/17 18:10
-	18	4983804.URPN.	USPAT	2003/10/17 18:14
-	11	("2762892" | "3467806" | "4327265" | "4431891" | "4642442" | "4659912" | "4749833" | "4771151" | "4789767" | "4795870" | "4806107").PN.	USPAT	2003/10/17 18:17



	Document ID	Issue Date	Pages	Title	Current OR	Current XRef	R
12	US 5374809 A	19941220	14	Induction heating coupler and annealer	219/633	148/573; 219/634;	
13	US 4983804 A	19910108	11	Localized soldering by inductive heating	219/616	219/635; 219/656	
14	US 5504309 A	19960402	8	Induction heater having feedback control responsive	219/663	219/665; 219/666	
15	US 5343023 A	19940830	9	Induction heater having a power inverter and a	219/661	219/663; 219/665;	
16	US 6384339 B1	20020507	11	Printed circuit board assembly having adhesive	174/254	174/259; 361/749	
17	US 6288376 B1	20010911	22	Method and apparatus for melting a bump by induction	219/635	219/603; 219/616;	
18	US 6283358 B1	20010904	12	System for forming contacts on a semiconductor component	228/180.21	228/262.4; 228/49.5;	
19	US 5390079 A	19950214	11	Tape carrier package	361/749	257/674; 257/675;	
20	US 5101086 A	19920331	6	Electromagnetic inductor with ferrite core for	219/632	219/619; 219/660;	
21	US 5675891 A	19971014	14	Method of inductively soldering electrical	29/879	29/747; 439/879;	
22	US 4028118 A	19770607	20	Thermochromic materials	106/31.19	428/199; 428/29;	
23	US 6188506 B1	20010213	4	Conductive color-changing ink	359/288		
24	US 6616332 B1	20030909	14	Optical techniques for measuring parameters such as	374/162	116/216; 219/444.1;	
25	US 5547283 A	19960820	11	Optical temperature sensor using thermochromic	374/162	252/408.1; 252/962	
26	US 5340537 A	19940823	8	Temperature indicating compositions	422/26	422/28; 428/913;	

US 20030115749	20030626	Inductive heating of microelectronic components	29/848	Chen, Jimmy Kuo
US 5958266 A	19990928	Method of plasma incision of matter with a specifically tuned radiofrequency electromagnetic field gen	219/121.59	Fugo, Richard J. et al.
US 6278093 B1	20010821	Industrial apparatus to heat foodstuffs, particularly meat-products, by means of a radio frequency osci	219/601	Iacovacci, Vittorio et al.
US 6229131 B1	20010508	Microwave cooking grill and steamer	219/731	Koochaki, Kamel K.
US 5925455 A	19990720	Electromagnetic-power-absorbing composite comprising a crystalline ferromagnetic layer and a dielec	428/328	Bruzzone, Charles L. et
US 5403376 A	19950404	Particle size distribution for controlling flow of metal powders melted to form electrical conductors	75/255	DeVolk, Gerald A. et al.
US 4503306 A	19850305	High frequency heating appliance	219/750	Nobue, Tomotaka et al.
US 3811940 A	19740521	HIGH FREQUENCY HEATING METHOD FOR VAPOR DEPOSITION OF COATINGS ONTO FILAME	427/595	Douglas, Frank C. et al.
WO 2054833 A1	20020711	tN APPLIANCE FOR THE EQUALISATION OF HEAT IN A DIELECTRIC LOAD HEATED BY AN OSCILLATING		EKEMAR, LARS
US 6475822 B2	20021105	Method of making microelectronic contact structures	438/52	Eldridge, Benjamin N. et
US 6150186 A	20001121	Method of making a product with improved material properties by moderate heat-treatment of a metal	438/14	Chen, Jimmy Kuo-Wei e
US 6307161 B1	20011023	Partially-overcoated elongate contact structures	174/260	Grube, Gary W. et al.
US 6259155 B1	20010710	Polymer enhanced column grid array	257/690	Interrante, Mario John et
US 6184053 B1	20010206	Method of making microelectronic spring contact elements	438/52	Eldridge, Benjamin N. et
US 5912046 A	19990615	Method and apparatus for applying a layer of flowable coating material to a surface of an electronic co	427/126.2	Eldridge, Benjamin N. et
US 5476211 A	19951219	Method of manufacturing electrical contacts, using a sacrificial member	228/180.5	Khandros, Igor Y.
US 6035805 A	20000314	Method and apparatus for vacuum deposition of highly ionized media in an electromagnetic controlled	118/723VE	Rust, Ray Dean
US 6590267 B1	20030708	Microelectromechanical flexible membrane electrostatic valve device and related fabrication methods	257/415	Goodwin-Johansson, Sc
US 6373682 B1	20020416	Electrostatically controlled variable capacitor	361/278	Goodwin-Johansson, Sc
US 6283829 B1	20010904	In situ friction detector method for finishing semiconductor wafers	451/8	Molnar, Charles J
US 6275320 B1	20010814	MEMS variable optical attenuator	359/237	Dhuler, Vijayakumar R. e
US 5938839 A	19990817	Method for forming a semiconductor device	117/104	Zhang, Hongyong
US 5928598 A	19990727	Method of making a microelectronic device package	264/446	Anderson, Michael John
US 5855686 A	19990105	Method and apparatus for vacuum deposition of highly ionized media in an electromagnetic controlled	118/723VE	Rust, Ray Dean
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US 5673139 A	19970930	Microelectromechanical television scanning device and method for making the same	359/291	Johnson, Michael D.
US 5417494 A	19950523	Contactless testing of electronic materials and devices using microwaves	374/5	Kempa, Krzysztof et al.
US 4355221 A	19821019	Method of field annealing an amorphous metal core by means of induction heating	148/108	Lin, Kou C.
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US 5695564 A	19971209	Semiconductor processing system	118/719	Imahashi, Issei
US 5609820 A	19970311	Apparatus for rendering medical materials safe	422/23	Bridges, Jack E. et al.
US 5175239 A	19921229	Process for making para-aramid fibers having high tenacity and modulus by microwave annealing	528/348	Gauntt, Sibbley P. et al.
US 4777336 A	19881011	Method for treating a material using radiofrequency waves	219/696	Asmussen, Jes
US 6548303 B2	20030415	Method and apparatus for rapid fat content determination	436/23	Collins, Michael J. et al.
US 6184509 B1	20010206	Heating apparatus and heating element assembly method	219/633	Scott, Gerald R. F. et al
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US 6508920 B1	20030121	Apparatus for low-temperature annealing of metallization microstructures in the production of a microe	204/194	Ritzdorf, Thomas L. et a
US 5844216 A	19981201	System and apparatus for reducing arcing and localized heating during microwave processing	219/762	Fathi, Zakaryae et al.
US 6336269 B1	20020108	Method of fabricating an interconnection element	29/885	Eldridge, Benjamin N. et
US 6236491 B1	20010522	Micromachined electrostatic actuator with air gap	359/291	Goodwin-Johansson, Sc
US 6087266 A	20000711	Methods and apparatus for improving microloading while etching a substrate	438/714	Abraham, Susan C.
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